

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S8	10	((ion beam) near2 source) and ((plasma near3 (process\$4 generat\$4 chamber)) same ((first second) near3 electrode) same antenna)	US-PGPUB; USPAT; USOCR	OR	ON	2005/06/09 18:50
S13	11748	plasma with generat\$4 with chamber	US-PGPUB; USPAT; USOCR	OR	ON	2005/06/10 10:50
S14	25	(plasma with generat\$4 with chamber).ti	US-PGPUB; USPAT; USOCR	OR	ON	2005/06/09 19:38
S15	10277	(plasma with generat\$4 with chamber)	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/09 19:39
S16	87	S15 and antenna and (electrode grid)	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/09 19:51
S24	5261	plasma and antenna and electrode	US-PGPUB; USPAT; USOCR	OR	ON	2005/06/10 10:51
S25	850	S24 and ((high near frequency HF) near3 (power voltage supply source)) and ((bias DC direct near current) near3 (power voltage supply source))	US-PGPUB; USPAT; USOCR	OR	ON	2005/06/10 10:54
S26	206	S25 and (((high near frequency HF) near3 (power voltage supply source)) same antenna) and (((bias DC direct near current) near3 (power voltage supply source)) same electrode)	US-PGPUB; USPAT; USOCR	OR	ON	2005/06/10 10:55
S35	5261	plasma and antenna and electrode	US-PGPUB; USPAT; USOCR	OR	ON	2005/06/10 15:25
S36	850	S35 and ((high near frequency HF) near3 (power voltage supply source)) and ((bias DC direct near current) near3 (power voltage supply source))	US-PGPUB; USPAT; USOCR	OR	ON	2005/06/10 15:25
S37	206	S36 and (((high near frequency HF) near3 (power voltage supply source)) same antenna) and (((bias DC direct near current) near3 (power voltage supply source)) same electrode)	US-PGPUB; USPAT; USOCR	OR	ON	2005/06/10 15:25